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AF

RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1743  
**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q60006

Hiromoto OHNO, et al.

Appln. No.: 09/822,211

Group Art Unit: 1743

Confirmation No.: 9864

Examiner: Monique T. COLE

Filed: April 2, 2001

For: MEASURING METHOD FOR CONCENTRATION OF HALOGEN AND FLUORINE COMPOUND,  
MEASURING EQUIPMENT THEREOF AND MANUFACTURING METHOD OF HALOGEN  
COMPOUND

**RESPONSE UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Response is submitted in response to the Office Action dated September 22, 2005.

Review and reconsideration on the merits in view of the following remarks and amendments is respectfully requested.

**TABLE OF CONTENTS**

REMARKS..... 2